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Experimental and Theoretical Studies of Serpentine Microstructures Bonded To Prestrained Elastomers for Stretchable Electronics

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Stretchable electronic devices that exploit inorganic materials are attractive due to their combination of high performance with mechanical deformability, particularly for applications in biomedical devices that require intimate integration with human body. Several mechanics and materials schemes have been devised for this type of technology, many of which exploit deformable interconnects. When such interconnects are fully bonded to the substrate and/or encapsulated in a solid material, useful but modest levels of deformation (<30-40%) are possible, with reversible and repeatable mechanics. Here, the use of prestrain in the substrate is introduced, together with interconnects in narrow, serpentine shapes, to yield significantly enhanced (more than two times) stretchability, to more than 100%. Fracture and cyclic fatigue testing on structures formed with and without prestrain quantitatively demonstrate the possible enhancements. Finite element analyses (FEA) illustrates the effects of various material and geometric parameters. A drastic decrease in the elastic stretchability is observed with increasing metal thickness, due to changes in the buckling mode, that is, from local wrinkling at small thicknesses to absence of such wrinkling at large thicknesses, as revealed by experiment. An analytic model quantitatively predicts the wavelength of this wrinkling, and explains the thickness dependence of the buckling behaviors.

1. Introduction

Recent research has led to rapid advances in stretchable electronics and optoelectronics technologies.^[1-9] When implemented with high quality inorganic semiconductors, these systems can offer the performance of conventional waferbased devices, but with the mechanics of a rubber band, to allow stretching, compressing, bending, twisting and conformal wrapping onto arbitrarily curvilinear surfaces.[10–15] Such unique characteristics pave the way to applications ranging from wearable photovoltaics^[16] to curvilinear digital cameras, [17,18] to systems that can naturally integrate with the human body, to those that exploit bio-inspired designs.^[8,19–22] One popular approach to stretchable properties involves an island-bridge layout, [8,9,23-26] in which the active components reside at the islands, and the electrical interconnects form the bridges.

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Upon stretching, the interconnects (which have low effective stiffness) deform to provide the stretchability, while the rigid devices (which have high effective stiffness) undergo negligible deformations (usually <1% strain) to ensure mechanical integrity of the functional materials. At least two classes of interconnect structures have been proposed: 1) straight ribbons with non-coplanar arc-shapes, [23,24,27] sometimes enabled by trenches in the substrate^[24]; 2) serpentine traces^[2,8,21,28–35] composed of arcs and straight lines, which also involve non-coplanar geometries, in either or both the as-fabricated and as-deformed states. The second embodiment offers improved stretchability for a given space between adjacent islands. Based on different structural designs and fabrication processes, the serpentine interconnect can be fully bonded, partially bonded, or completely non-bonded to the elastomer substrate, each with different advantages/disadvantages for various application requirements. Non-bonded interconnects can deform freely, via lateral buckling in terms of out-of-plane bending and twisting, [25,36,37] and most effectively for the case of ultra-thin geometries (thicknesses ≈ 100 nm, as compared to widths ≈ 10 micrometers), to reduce the strain energy. The stretchability then simply increases with the total length of the interconnect, [25,26,38] and can reach values as large as ≈200%. [26] An obvious disadvantage, however, is that exposure of these interconnects to the outside environment can lead to damage of these structures or of adjacent materials by physical contact.[8,21] Encapsulation provides a solution, but the thickness of the encapsulant must be sufficient to encase the buckled interconnects. In this regime, the motions of the interconnects will be highly constrained if solid encapsulants (e.g., Ecoflex, PDMS), [26] rather than fluid encapsulants [e.g., uncured PDMS prepolymer (viscous liquid), [26] gel electrolytel [9] are used. Interconnects that are fully bonded to (or embedded in) the elastomeric substrate offer an alternative. [8,21,26] Under this circumstance, as with the solid encapsulant, constraints restrict the motion of the interconnect. $^{[8,\hat{2}1,26]}$ The result is that a given deformation leads to a higher strain level in this case as compared to the non-bonded, unencapsulated (or fluid encapsulated) configuration. For such designs, the elastic stretchability (for 0.3% yield strain of metals) and total stretchability (for 5% fracture strain of metals) of the interconnect will be reduced to below 50% and 150%, respectively. These values translate to ≈20% and ≈60% elastic and total stretchabilities, respectively, for systems with ≈36% fill factor of active devices, with further reductions to ≈10% and \approx 30%, respectively, for fill factors of \approx 64%. This level of elastic stretchability can be too low for some of the most demanding biomedical applications, where the strains (e.g., skin, heart, or elbow) may exceed 20%. In general, the stretchability in islandbridge systems is related to the stretchability of the interconnects by (see Supporting Information for details):

stretchability of the system =
$$\left(1 - \sqrt{\text{fill factor}}\right) * \text{(stretchability of the interconnect)}$$
 (1)

This paper outlines strategies and considerations for ultrastretchable electrical interconnects that are fully bonded to a soft substrate and, at the same time, offer elastic stretchability >40% by combining use of prestrain in the supporting substrate with serpentine layouts in the interconnects. For fully bonded interconnects, previous studies were mainly focused either on straight interconnects bonded to prestrained (or unstrained) substrate, [1,2,22,28,39] or on serpentine interconnect bonded to unstrained substrate. [8,21,30,32,33,37] Combined use of prestrain and serpentine interconnects has not been explored. In this study, several mechanisms of deformation are identified, and the elastic and total stretchabilities are determined through combined analytical modeling, numerical simulations, and experimental observations. The results are useful for the design of electronics with large elastic stretchability and/or high fill factor of active devices, for potential applications in solar cells, [16,24] energy storage systems, [9] and biomedical devices. [8,21]

2. Use of Substrate Prestrain for Fully Bonded Serpentine Interconnects

A schematic illustration of the prestrain strategy appears in **Figure 1**a. Serpentine interconnects are transfer printed and bonded onto a stretched substrate; releasing the strain causes deformations in the interconnect that configure it into a form with enhanced stretchability. Scanning electron microscope (SEM) images in Figure 1b,c show a serpentine interconnect before and after release of prestrain ($\varepsilon_{\text{prestrain}} = 160\%$) of a soft silicone (Ecoflex, Smooth-On, Inc) substrate. The interconnect is 50 μ m wide, and uses copper and polyimide (PI) in a multilayer structure of PI/Cu/PI (Figure 1d), with thicknesses of 1.2, 0.3 and 1.2 μ m, respectively.

For computational purposes, we define the elastic stretchability as the magnitude of applied strain needed to reach a typical yield strain $(0.3\%)^{[40]}$ for the interconnect metal. Similarly, we define the total stretchability as the applied strain needed to reach a fracture strain $(5\%)^{[41]}$ in the metal. The PI has yield and fracture strains (>10%) that are much larger than those for the metal, [42] such that strain in the metal limits the stretchability, for cases examined here, in spite of the fact that the strain in the PI is typically higher than that in the metal.

A representative unit cell of a serpentine interconnect consists of two half circles, and two straight lines with the length l_2 and spacing l_1 (Figure 1d). Let m denote the number of unit cells in each serpentine interconnect; w the width; $t_{\rm metal}$ the thickness of metal layer, and $t_{\rm PI1}$ and $t_{\rm PI2}$ the thickness of bottom and top PI layers. Two examples with a thin metal layer ($t_{\rm metal}=0.3~\mu{\rm m},~t_{\rm PI1}=t_{\rm PI2}=1.2~\mu{\rm m}$) and a relatively thick one ($t_{\rm metal}=4.0~\mu{\rm m},~t_{\rm PI1}=4.0~\mu{\rm m},~t_{\rm PI2}=0$) are studied in the following to illustrate the advantages of prestrain strategy. The other parameters are $l_1=l_2=500~\mu{\rm m},~w=50~\mu{\rm m},$ and m=3. Both FEA (see Supporting Information for details) and experiments (see Section 6 for details) reveal the effect of prestrain on the elastic and total stretchabilities.

Figure 2a shows the deformed configurations after release of prestrains of 40%, 80%, and 160% for the case of a serpentine interconnect with thin copper ($t_{\rm metal} = 0.3~\mu m$, $t_{\rm PI1} = t_{\rm PI2} = 1.2~\mu m$). The SEM images show excellent agreement with the FEA results. Both indicate that the interconnect accommodates the large compression associated with release of prestrain in such a manner that the arc segments (of semicircles) experience buckling (via out-of-plane bending and

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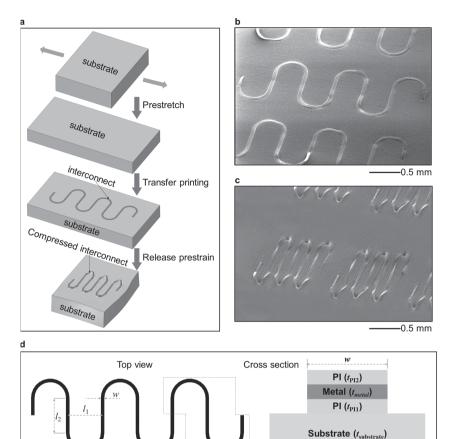


Figure 1. a) Schematic illustration of the prestrain strategy for fabricating serpentine interconnects with enhanced levels of stretchability; b) SEM image of the serpentine structures before releasing the prestrain of the substrate; c) SEM image of the serpentine interconnect after releasing the prestrain of the substrate; d) illustration of geometric parameters for a serpentine interconnect, with top and cross-sectional views.

twisting) to shorten the spacing between the straight segments (Figures 1c, 2a). The straight segments undergo minor in-plane bending since they remain vertical during compression. The level of compression can be estimated by $\varepsilon_{\text{prestrain}}/(1 + \varepsilon_{\text{prestrain}})$ since the tensile stiffness of the buckled serpentine interconnect is negligible compared to that of the substrate.^[8] If we refer to the prestretched state of substrate as the base configuration, then upon release of the prestrain, the substrate will undergo large tensile deformation along the vertical direction due to the Poisson effect. The strain transferred to the interconnect, however, is small, since the interconnect is mostly straight along the vertical direction and is much stiffer than the soft silicone elastomer underneath. Based on our FEA, the magnitude of normal strain along the vertical direction is less than ~0.3% in the metal for 85% prestrain, as shown in Figure S1, Supporting Information.

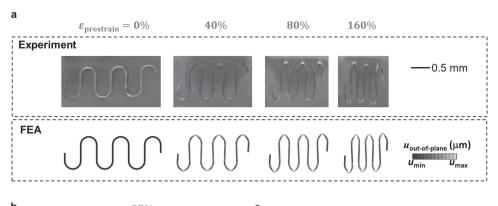
For prestrains (e.g., up to $\approx 85\%$ for Figure 2a) that avoid plastic deformation in the compressed serpentine interconnect (upon release of the prestrain), the interconnect can be stretched to exactly the same configuration just prior to fracture as an otherwise similar interconnect configured without

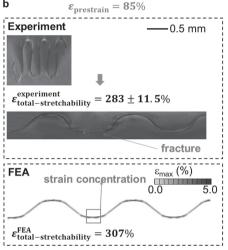
using prestrain. By consequence, the prestrain increases the stretchability. When the interconnect/substrate system is stretched, the strain is much lower (e.g., ≈250 times in the example shown in Figure S2, Supporting Information) in the metal interconnect than that in the substrate, indicating effective strain isolation and high system stretchability. The strain concentration in the substrate is most evident in the regions near the interconnect/substrate interface. Away from those regions, the strain is rather uniform. For the case shown in Figure 2a, with 85% prestrain, FEA predicts 189% elastic stretchability and 307% total stretchability. Both values are much larger than the computed elastic (48%) and total (120%) stretchabilities without the prestrain. These results agree with experiments (Figures 2, 3a), which show an increase of elastic stretchability from 53% (0-prestrain) to 185% (85%-prestrain) by cyclic testing (see Experimental Section for details), and total stretchability from 137% \pm 10.6% (0-prestrain) to 283% \pm 11.5% (85%-prestrain) (Figure 2c). The fracture limits in Figure 2c are defined as the onset of loss in electrical conductance (see Supporting Information, Figure S3, for original electrical measurement data), rather than the observation of physical/mechanical fracture. The top frame of Figure 2b shows the serpentine interconnect after release of prestrain (85%); the middle frame illustrates its fracture around the arc segment when the applied strain exceeds the total stretchability (≈300%), which is in agreement with FEA (bottom frame) predictions that the strain in the copper reaches the fracture strain (5%)

around the arc segment. The top left frame of Figure 3a corresponds to the top frame of Figure 2b. The optical microscope image in the top right frame clearly shows that there are no cracks after release of prestrain; the middle frames illustrate fatigue induced cracking after 25 000 cycles (i.e., a low-cycle test, [43,44] which is large enough to observe fatigue caused by plastic deformation) of stretching and relaxing with a strain amplitude of 185%. Here, many micro-cracks form at the inner sides of the semicircles, which is also consistent with FEA results in the bottom frame that show plastic yielding at the predicted elastic stretchability (189%). This elastic stretchability is much larger than that of samples without prestrain (53%, see Figure S4, Supporting Information, for details). Experimental results show that 25 000 cycles of stretching/relaxing to strains lower than those defined by modeling to lie in the elastic range do not induce cracks (Figure S4b, Supporting Information) for both prestrained and non-prestrained samples. Equation 1 then gives the elastic and total stretchabilities of the system.

To demonstrate the potential for use of prestrained serpentine structures in devices, we measured their electrical resistance with a four point probe technique, during various levels of

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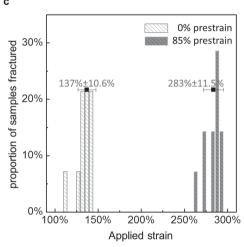


Figure 2. a) Experimental and numerical analyses of configurations of serpentine interconnects after relaxing different levels of prestrain; b) experimental image of the serpentine interconnect and the fracture sites due to one-time stretching (300%), and FEA results for the strain distribution when stretched to the predicted total stretchability (307%), for the case of 85% prestrain; c) histogram showing proportions of fractured interconnects at different intervals of applied strain for non-prestrained samples and 85% prestrained samples. The interconnect consists of 0.3 µm thick copper sandwiched by two 1.2 µm thick PI layers. The grayscale in the FEA results (Figure 2a) represents the distribution of out-of-plane displacement, with the minimum and maximum values (u_{min} , u_{max}) given by (0, 0), (63.9, 131.6), (121.6, 214.4), (224.4, 360.0) for $\varepsilon_{pre} = 0\%$, 40%, 80%, 160%, respectively.

deformation. Two types of samples were prepared (serpentine interconnects on non-prestrained and 40%-prestrained substrates, see Figure 3b), and then stretched on a uniaxial tensile tester while changes in electrical resistance were recorded. To determine the transition from elastic to plastic deformation, the samples were repeatedly cycled between a state of zero strain and a uniaxial strain at a level incremented by ≈10% in sequential tests. In the elastic region, the resistance remained (almost) unchanged upon the cycles, until reaching a plastic deformation region, characterized by an increased resistance (related to non-recoverable deformation). It should be noted that small changes in electrical resistance due to fluctuations in temperature were accounted for and subtracted by simultaneously measuring the local temperature during testing. The experiment results are shown in Figure 3c, where the elastic ranges were determined to be 54% for non-prestrained samples and 120% for 40%-prestrained samples. The results agree reasonably well with corresponding FEA findings (48% and 108%).

For the serpentine interconnect with thick copper ($t_{\text{metal}} =$ 4.0 μ m, t_{PI1} = 4.0 μ m, t_{PI2} = 0), numerical and experimental results (Supporting Information, Figures S4,S5) also show significant increases in elastic stretchability (from 11% to 31% in FEA and 16% to 39% in experiment for 18% prestrain, Supporting Information, Figures S4c,d,S5c) and total stretchability (from 124% to 304% in FEA and 103% to 286% in experiment for 85% prestrain, Supporting Information, Figures S5b).[46]

The numerical methods, validated by experiments as in Figures 2, 3 and Figures S4,S5 (Supporting Information), can now be used in the following sections to study the prestrain strategy for various materials and geometric parameters of serpentine interconnect and substrate.

3. Use of Substrate Prestrain with Interconnects **Constructed using Various Materials and Layouts**

This section summarizes the effects of key material and geometric parameters on the elastic stretchability of the serpentine interconnect, with or without prestrain. The prestrain is set to the maximum value that avoids plastic yielding in the metal layer (for 0.3% yield strain) upon release.

Figure 4 illustrates the effects of Young's moduli (E) of the metal layer and substrate on the elastic stretchability, including Al, Au, Cu, Ni, and Cr; and Ecoflex, Solaris, and PDMS with

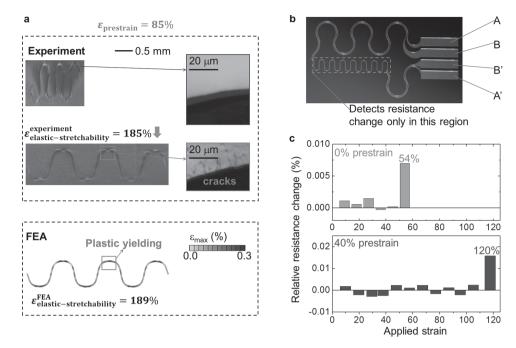


Figure 3. a) Experimental image of the serpentine interconnect and the fracture sites due to cyclic stretching (with an amplitude of 185%), and FEA results for the strain distribution when stretched to the predicted elastic stretchability (189%), for the case of 85% prestrain. b) 4-point probe samples. The four terminals are marked as A, B, B', and A'. The current was supplied via A and A', while the generated voltage is measured via B and B'. The separation of current (A and A') and voltage electrodes (B and B') eliminates the resistance contribution of the wiring and contact resistances, therefore giving more accurate resistance measurement. c) relative resistance change versus applied strain. The interconnect consists of 0.3 µm thick copper sandwiched by two 1.2 μm thick PI layers.

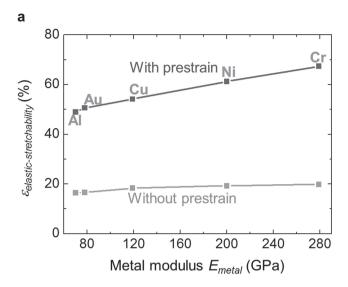
different mixing ratios. The corresponding maximum prestrain for each material system is given in Figure S6, Supporting Information. For curves with or without the prestrain, the elastic stretchability increases as the Young's modulus of metal layer $E_{\rm metal}$ increases, or that of the substrate $E_{\rm substrate}$ decreases. The prestrain strategy always enhances the elastic stretchability over the case without the prestrain, typically by a factor between 2.3 and 3.5.

Figures 5a and Figure S7a (Supporting Information) show the elastic stretchability and maximum prestrain (to avoid plastic yielding) versus the length/spacing ratio ($\alpha = l_2/l_1$) of the interconnect. The elastic stretchability increases with α for α < 1; it saturates (for the curve without prestrain), or reaches the maximum (for the curve with prestrain), for $\alpha \sim 1$. This behavior results because, as the length b increases from zero, the straight segment bends within the substrate surface to yield additional capacity for stretching. However, as l_2 exceeds l_1 , the straight segment becomes quite stiff and cannot be bent to provide additional stretchability. This effect is illustrated in Figure S8 (Supporting Information), which shows significant bending (in-plane rotation) of the straight segments for $\alpha = 0.5$, but almost no bending for $\alpha = 2$ and 3. For other metal thickness (e.g., 0.3 or $3.0 \mu m$ instead of $1.0 \mu m$), the elastic stretchability exhibits similar dependence on the aspect ratio, but such that the point of saturation shifts, as shown in Figure S9 (Supporting Information). The elastic stretchability is insensitive to the substrate thickness (Figure 5b) (with the maximum prestrain given in Figure S7b, Supporting Information), for cases when the substrate is much thicker than the interconnect. The elastic stretchability, however, increases rapidly as the

metal thickness decreases from 4.0 µm to 0.3 µm (Figure 5c) (with the maximum prestrain given in Figure S7c, Supporting Information). This drastic increase in the elastic stretchability is due to different buckling modes for thin and relatively thick metal layers, as discussed later. All results in Figure 5 confirm a significant increase in elastic stretchability due to prestrain. In particular, for very thin metal ($t_{\rm metal}$ < 0.45 μ m), the elastic stretchability exceeds 100%. This result corresponds to 40% stretchability of the system (for ≈36% fill factor of active devices), which is suitable for many biomedical applications.

To reveal further aspects of buckling modes, we study, for simplicity, the case without prestrain. (The mechanisms are the same as those with prestrain.) Both experiment and FEA in **Figure 6**a show that a thin serpentine interconnect ($t_{\text{metal}} =$ 0.3 μ m, $t_{PI1} = t_{PI2} = 1.2 \mu$ m) under stretching undergoes not only in-plane bending but also local, out-of-plane wrinkling as reflected by the sharp grayscale changes in the contours of out-of-plane displacement in FEA as well as by the variation of grayscale (also relating to the out-of-plane displacement) in the SEM images. For a relatively thick interconnect $(t_{\text{metal}} = 4.0 \ \mu\text{m}, \ t_{\text{PI}1} = 4.0 \ \mu\text{m}, \ t_{\text{PI}2} = 0 \ \mu\text{m})$, Figure 6b shows almost no local wrinkling deformation, and the interconnect only undergoes in-plane bending together with some twisting around the arc region (see Figure S10, Supporting Information) because of the high strain energy associated with local wrinkling of the thick metal layer. An analytical model without prestrain, in view of buckling mechanics of thin film on compliant substrate, [45] appears in the next section. The results allow study of the elastic stretchability for these two buckling modes.

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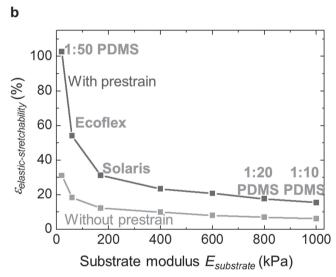
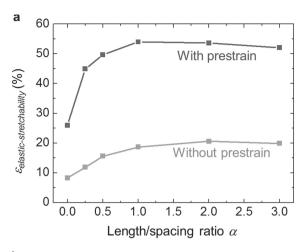


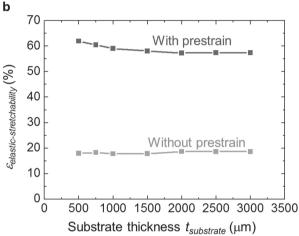
Figure 4. Influence of material parameters (**a** for metal modulus, and **b** for substrate modulus) on the elastic stretchability of serpentine interconnects with and without prestrain. The parameters adopted in the simulations are ($l_1 = l_2 = 500 \, \mu m$, $w = 50 \, \mu m$, m = 3, $t_{\rm metal} = 1.0 \, \mu m$, $t_{\rm Pl1} = t_{\rm Pl2} = 1.2 \, \mu m$, $t_{\rm substrate} = 1.0 \, m m$, $E_{\rm substrate} = 60 \, {\rm kPa}$) in Figure 4a, and ($l_1 = l_2 = 500 \, \mu m$, $w = 50 \, \mu m$, m = 3, $t_{\rm metal} = 1.0 \, \mu m$, $t_{\rm Pl1} = t_{\rm Pl2} = 1.2 \, \mu m$, $t_{\rm substrate} = 1.0 \, m m$, $E_{\rm metal} = 119 \, {\rm GPa}$) in Figure 4b.

4. An Analytical Model for the Buckling Modes

Due to its small thickness ($\approx 1~\mu m$, << the width $\approx 100~\mu m$), [8.25,26] a free-standing interconnect is susceptible to buckling during deformation, in the form of out-of-plane bending and twisting. For a fully-bonded interconnect, the constraint from the substrate tends to suppress the out-of-plane deformation such that the strain energy in both the substrate and interconnect must be included. [45]

Jiang et al. [45] studied a silicon thin film bonded to a prestrained elastomeric substrate. Release of the prestrain ($\varepsilon_{\text{prestrain}}$) in the substrate leads to an average compression





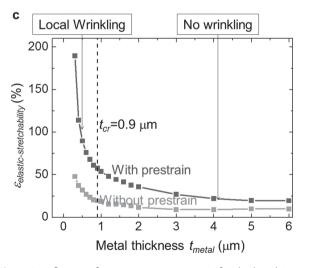
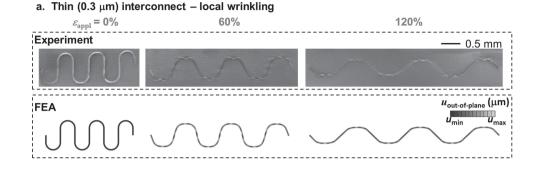


Figure 5. Influence of geometric parameters (a for the length/spacing ratio, **b** for substrate thickness, and **c** for metal thickness) on the elastic stretchability of serpentine interconnects with and without prestrain. The parameters adopted in the simulations are ($l_1 = 500 \, \mu m$, $w = 50 \, \mu m$, m = 3, $t_{\text{metal}} = 1.0 \, \mu m$, $t_{\text{Pl}1} = t_{\text{Pl}2} = 1.2 \, \mu m$, $t_{\text{substrate}} = 1.0 \, m m$, $E_{\text{substrate}} = 60 \, \text{kPa}$, $E_{\text{metal}} = 119 \, \text{GPa}$) in Figure 5a, ($l_1 = l_2 = 500 \, \mu m$, $w = 50 \, \mu m$, m = 3, $t_{\text{metal}} = 1.0 \, \mu m$, $t_{\text{Pl}1} = t_{\text{Pl}2} = 1.2 \, \mu m$, $E_{\text{substrate}} = 60 \, \text{kPa}$, $E_{\text{metal}} = 119 \, \text{GPa}$) in Figure 5b, and ($l_1 = l_2 = 500 \, \mu m$, $w = 50 \, \mu m$, m = 3, $t_{\text{Pl}1} = t_{\text{Pl}2} = 1.2 \, \mu m$, $t_{\text{substrate}} = 60 \, \text{kPa}$, $t_{\text{metal}} = 1.0 \, m m$, $t_{\text{substrate}} = 60 \, \text{kPa}$, $t_{\text{metal}} = 1.0 \, m m$, $t_{\text{substrate}} = 60 \, \text{kPa}$, $t_{\text{metal}} = 1.0 \, m m$, $t_{\text{substrate}} = 60 \, \text{kPa}$, $t_{\text{metal}} = 1.0 \, m m$, $t_{\text{substrate}} = 60 \, \text{kPa}$, $t_{\text{metal}} = 1.0 \, m m$, $t_{\text{substrate}} = 60 \, \text{kPa}$, $t_{\text{metal}} = 1.0 \, m m$, $t_{\text{substrate}} = 1.0 \,$



b. Thick (4 μ m) interconnect – no wrinkling $\varepsilon_{\rm appl} = 0\%$ 60%



Figure 6. Experiment and numerical analyses of the evolution of deformed configurations of serpentine interconnects under stretching. a) sample consisting of 0.3 μm thick copper sandwiched by two 0.3 μm thick PI layers, and b) sample consisting of a 4.0 μm thick copper on a 4.0 μm thick PI layer. The grayscale in the FEA results represents the distribution of out-of-plane displacements, with the minimum and maximum values (u_{min} , u_{max}) given by (0, 0), (–120.8, –65.0), (–168.8, –113.2) in Figure 6a, and (0, 0), (–179.0, –30.4), (–215.3, –77.0) in Figure 6b, for ε_{appl} = 0%, 60%, 120%, respectively.

 $\varepsilon_{\rm compression}=\varepsilon_{\rm prestrain}/\left(1+\varepsilon_{\rm prestrain}\right)$ in the thin film, which initiates buckling. Note that Jiang et al. [45] adopted " $\varepsilon_{\rm pre}$ " in their formulae instead of " $\varepsilon_{\rm prestrain}$ " in the current work. The buckling wavelength is given by [45]

$$\lambda = \frac{2\pi t_f \left(\frac{E_f}{3E_s}\right)^{1/3}}{\left(1 + \varepsilon_{\text{prestrain}}\right) \left[1 + \frac{5}{32} \varepsilon_{\text{prestrain}} \left(1 + \varepsilon_{\text{prestrain}}\right)\right]^{1/3}}$$

$$= \frac{2\pi \left(\frac{4S_f}{E_s}\right)^{1/3}}{\left(1 + \varepsilon_{\text{prestrain}}\right) \left[1 + \frac{5}{32} \varepsilon_{\text{prestrain}} \left(1 + \varepsilon_{\text{prestrain}}\right)\right]^{1/3}}, \tag{2}$$

where $t_{\rm f}$ is the film thickness, $\bar{E}=E/(1-v^2)$ denotes the plane-strain modulus (ν is the Poisson ratio), $S_f=\bar{E}_{\rm f}t_{\rm f}^3/12$ is the bending stiffness of the thin film (per unit width), and the subscripts "f" and "s" represent the thin silicon film and substrate, respectively.

For a serpentine interconnect bonded to a soft substrate subject to stretching ε_{appl} along the horizontal direction (Figure 1d), the straight segment in the vertical direction in the serpentine interconnect undergoes compression due to the Poisson effect; and the compressive strain along the vertical (transverse) direction is given by $\varepsilon_{\text{compression}} = 1 - \left(1 + \varepsilon_{appl}\right)^{-1/2}$ since the soft substrate is nearly incompressible (i.e., $\nu = 0.5$). Equivalence of this compressive strain to that in Jiang et al.'s theory^[45] gives the equivalent prestrain

$$\varepsilon_{\text{prestrain}} = \sqrt{1 + \varepsilon_{\text{appl}}} - 1$$
 (3)

120%

0.5 mm

in the substrate. For the interconnect with multi-layer structure (PI/metal/PI), the equivalent bending stiffness is given by

$$S_{\rm f} = \sum_{i=1}^{3} \bar{E}_i t_i \left\{ b + \frac{t_i}{2} - \sum_{j=1}^{i} t_j \right\}^2 + \frac{1}{12} \sum_{i=1}^{3} \bar{E}_i t_i^3, \tag{4}$$

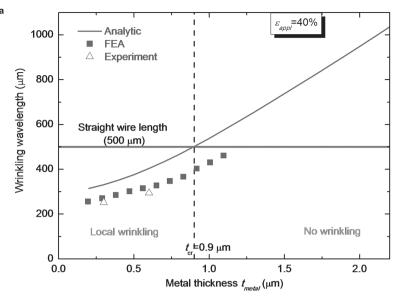
where i = 1,2,3 represents the bottom PI layer, metal layer, and top PI layer, respectively, and b is the distance of the neutral mechanical plane from the bottom surface of the interconnect and is given by

$$b = \frac{\sum_{i=1}^{3} \left[\bar{E}_{i} t_{i} \left(-\frac{t_{i}}{2} + \sum_{j=1}^{i} t_{j} \right) \right]}{\sum_{i=1}^{3} \bar{E}_{i} t_{i}}.$$
 (5)

Substitution of Equation 3 into Equation 2 gives an estimate of the buckling wavelength of the straight segment in the serpentine interconnect as

$$\lambda = 2\pi \left(\frac{4S_{\rm f}}{\bar{E}_{\rm s}}\right)^{1/3} g\left(\varepsilon_{\rm appl}\right),\tag{6}$$

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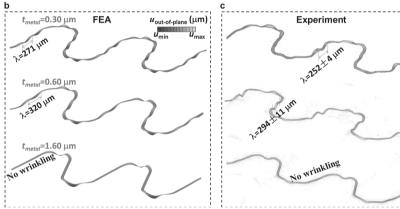


Figure 7. a) Dependence of wrinkling wavelength on the metal thickness, based on experiment, numerical simulations and analytic modeling; b) numerical results and c) 3D CT scanning images of the deformed configurations for three typical metal thicknesses to illustrate the different buckling modes. The grayscale in the FEA results (Figure 7b) represents the distribution of out-of-plane displacement, with the minimum and maximum values (u_{min} , u_{max}) given by (-102.5, -47.1), (-106.8, -44.1) and (-145.3, -44.0) for 0.3 μ m, 0.6 μ m, and 1.6 μ m, respectively.

where $S_{\rm f}$ is given in Equation 4 and $g\left(\varepsilon_{\rm appl}\right) = \left[1+\frac{5}{32}\left(1+\varepsilon_{\rm appl}-\sqrt{1+\varepsilon_{\rm appl}}\right)\right]^{-1)3}\left/\sqrt{1+\varepsilon_{\rm appl}}\right|$ is a function of the applied strain. For a representative cross section with $t_{PI1} = t_{PI2} = t_{PI}$, the buckling wavelength can be further simplified as

$$\lambda = 2\pi \left[\frac{\bar{E}_{\text{PI}}}{3\bar{E}_{\text{s}}} \left(2t_{\text{PI}} + t_{\text{metal}} \right)^3 + \frac{\bar{E}_{\text{metal}} - \bar{E}_{\text{PI}}}{3\bar{E}_{\text{s}}} t_{\text{metal}}^3 \right]^{1/3} g \left(\varepsilon_{\text{appl}} \right) \quad (7)$$

Equation 7 shows that the buckling wavelength of the serpentine interconnect increases with the thickness of metal layer. For a very thin metal layer ($t_{\rm metal} \sim 0$), the wavelength becomes $\lambda = 4\pi t_{\rm Pl} \left[\bar{E}_{\rm Pl} / (3\bar{E}_{\rm s}) \right]^{1/3} g\left(\varepsilon_{\rm appl}\right)$, which is 144 µm for polyimide ($\bar{E}_{\rm Pl} = 2.83\,{\rm GPa}$ and $t_{\rm Pl} = 0.6\,{\rm \mu m}$) on an Ecoflex substrate ($\bar{E}_s = 79.00 \,\mathrm{kPa}$), subject to 40% applied strain. This value is much smaller than the length l_2 (e.g., 500 µm) of the straight segment, such that the local wrinkling

mode is observed. For thicknesses of the metal layer that are comparable to that of the PI, the wavelength in Equation 7 becomes $\lambda = 2\pi t_{\mathrm{metal}} \left[\bar{E}_{\mathrm{metal}} / (3\bar{E}_{\mathrm{s}}) \right]^{1/3} g \left(\varepsilon_{\mathrm{appl}} \right)$ because $\bar{E}_{\mathrm{metal}} \gg \bar{E}_{\mathrm{Pl}}$. The value is 1345 $\mu \mathrm{m}$ for copper ($\bar{E}_{copper} = 147.57 \, \text{GPa}$ and $t_{metal} =$ 3.0 µm) on an Ecoflex substrate, subject to 40% applied strain, which is larger than the length l₂ such that the local wrinkling mode is not observed. We propose the following analytic criterion for separating the two buckling modes:

local wrinkling if
$$\lambda < l_2$$
 no wrinkling if $\lambda \ge l_2$ (8)

For a copper serpentine interconnect fully attached to an Ecoflex substrate, with the thickness of each PI layer $t_{PI} = 1.2 \mu m$, Figure 7a shows that the above analytic criterion gives the critical thickness of metal layer separating two buckling modes as 0.9 µm, which is slightly underestimated as compared to experiments and FEA. Below this critical thickness of 0.9 µm, the elastic stretchability increases rapidly as the thickness of metal layer decreases, as illustrated in Figure 6c, mainly due to local wrinkling. Figure 7b,c show the three-dimensional configurations of the deformed serpentine interconnect from FEA and experiments (based on 3D micro-XCT scanning), respectively. Local wrinkling is clearly observed for thin metal layers (t_{metal} = 0.3 µm and 0.6 µm), and no wrinkling for relatively large metal layers (1.6 um and 4.0 um shown in Figure S10b, Supporting Information). The wavelengths given by FEA and experiments also agree very well.

5. Conclusions

This work shows that a prestrain strategy with bonded serpentine interconnects in island-bridge designs stretchable electronics yields significantly improved mechanics, in terms of range of stretchability and maximum material strains for any given level of deformation. Both experiment measurement and numerical simulations verify increases in the elastic and total stretchabilities to more than two times the original values. The effects of key material and geometric parameters on the elastic stretchability are outlined, and can be used in the development of future designs. Two different buckling modes, local wrinkling and no wrinkling, were revealed for serpentine interconnects with different metal thicknesses, through experiment and FEA. The associated mechanics results from a competition between the buckling wavelength and the length of the straight segments of the serpentine structure. An analytic model based on this mechanism enables analysis of the buckling wavelengths at different metal thicknesses, with good agreement with both experiment and FEA. The prestrain

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strategy is valid not only for the serpentine interconnect, but also for interconnects in other layouts, such as horseshoe patterns, [33] self-similar serpentine patterns, [9] and so on. It has general utility for future work in stretchable inorganic device systems, especially those that demand large coverage of active devices, such as stretchable photovoltaics^[16] and electronic eyeball cameras.[23]

6. Experimental Section

Fabrication of Fully Bonded Copper Interconnects on Silicone Substrates: Sequential spin-casting defined a bilayer of poly(methyl methacrylate) (PMMA 495, MicroChem, at speed of 3000 r.p.m. for 30 s, baked on a hotplate at 180 °C for 2 min) and a layer of polyimide (from poly(pyromellitic dianhydride-co-4,40-oxydianiline) amic acid solution; $\approx 1.2~\mu m$, Sigma Aldrich, 4000 r.p.m. for 40 s, baked on a hotplate at 150 °C for 5 min and then baked at 250 °C in vacuum for 1.5 h) on a silicon wafer. A layer of copper (300 nm. 600 nm. or 1.6 um) was then deposited by electron beam evaporation onto the polyimide (for thick wires of 4 µm copper foil is used instead of electron beam evaporation). Photolithography (AZ 4620) and etching (Type CE-100 copper etchant, Transene Company, at room temperature for ≈ 10 s) defined patterns in the metal layer. After removing the residual photoresist, spin coating formed an additional layer of polyimide (1.2 µm) over the entire structure. Next, photolithography (AZ 4620, 2000 r.p.m. for 30 s, baked at 110 °C for 4 min) and oxygen plasma etching (180 mTorr, 20 sccm O2, 200 Watt for 20 min) patterned the layers of polyimide in a geometry matched to the metal traces.

Immersion in hot acetone (80 °C) undercut the bottom PMMA layer, thereby allowing the entire structure to be retrieved from the silicon wafer onto the surface of a piece of water-soluble tape (3M). Electron beam evaporation of Cr (5 nm)/SiO₂ (50 nm) formed backside coatings to enhance adhesion between the patterned wires and receiving substrates. Silicone substrates (Ecoflex ≈1 mm thick, Smooth-On) were prepared by mixing the two components in a 1:1 weight ratio, casting the resulting material into a Petri dish and then partially curing it (17 h at room temperature and then 4 hours at 70 °C). Substrates were cut into desired dimensions and stretched with various level of strain (0%, 18%-160%). The surface of silicone substrate was treated with UV/Ozone for 4 min, after which the metal wires were transferred onto the silicone (with SiO₂ facing the substrate). The entire sample was then immersed in water for 12 h to dissolve the water-soluble tape, thereby completing the fabrication processes.

Mechanical Testing on the Prestrained Interconnects: Fracture testing of the interconnects was performed with a customized uniaxial stretcher. Optical microscopic, SEM, micro-XCT scanning (X-ray computed tomography, Xradia) images of the deformed interconnects were collected to measure a) the elongation of each interconnects along the stretching direction and b) wavelengths and amplitudes of local wrinkling.

Cyclic testing was performed with Fexural Endurance Tester (CK Trade, Korea) by sets of 25 000 cycles at 5 Hz. To determine the elastic stretchability of each sample, the strain level was gradually increased before any micro cracks were observed, and then new samples were tested under lower levels of strain to verify that they remained totally elastic (no cracks after a set of testing).

Supporting Information

Supporting Information is available from the Wiley Online Library or from the author.

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Supporting Information

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Experimental and Theoretical Studies of Serpentine Microstructures Bonded To Prestrained Elastomers for Stretchable Electronics

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Keywords: Stretchable Electronics; Flexible Electronics; Serpentine interconnect; Buckling analyses; Modeling

1. The dependence of the stretchability in island-bridge designs on the fill factor of active devices

The island-bridge design in stretchable electronics consists of rigid active components at the islands, and thin, flexible electrical interconnects as bridges. Since the active components are usually much stiffer than the interconnects, they undergo negligible deformation during stretching of the whole device. Therefore, the stretchability of the system is mainly determined by stretchability of the interconnect and the structural layout. For a typical square-shaped island with a fill factor of f, the stretchability of the system can be expressed in terms of the fill factor and the stretchability of the interconnect as

stretchability of the system =
$$(1 - \sqrt{f})^*$$
 (stretchability of the interconnect). (1)

2. Finite element analyses of the deformation behavior and stretchability

Three-dimensional finite element analyses (FEA) was adopted to examine the deformation behavior and stretchability of serpentine interconnects that are fully bonded to a soft elastomer substrate (Ecoflex). Eight-node 3D solid elements and four-node shell elements were used for the Ecoflex substrate and serpentine interconnect, respectively, and refined meshes were adopted to ensure the accuracy. Displacement boundaries were assigned to the side surfaces of substrate to apply different levels of stretching. The elastic modulus (E) and Poisson's ratio (v) are $E_{ecoflex} = 0.06$ MPa and $v_{ecoflex} = 0.49$ for Ecoflex; $E_{PI} = 2.5$ GPa and $v_{PI} = 0.34$ for PI; $E_{AI} = 70$ GPa and $v_{AI} = 0.35$ for aluminum; $E_{Au} = 78$ GPa and $v_{Au} = 0.44$ for gold; $E_{Cu} = 119$ GPa and $v_{Cu} = 0.34$ for copper; $E_{Ni} = 200$ GPa and $v_{Ni} = 0.31$ for nickel; and $E_{Cr} = 279$ GPa and $v_{Cr} = 0.21$ for chromium.

SI Figure Captions

Figure S1. Distribution of normal strain along the vertical direction in the metal layer of the interconnect before and after releasing the prestrain (85%). The interconnect consists of 0.3 μm thick copper sandwiched by two 1.2 μm thick PI layers.

Figure S2. Distribution of maximum principal strain in the entire system (a), the metal layer of the interconnect (b), and the substrate (c), respectively, under 40% stretching. The interconnect consists of 0.3 μm thick copper sandwiched by two 1.2 μm thick PI layers.

Figure S3. Resistance measurements to determine the fracture limits of serpentine interconnects with 0% prestrain (square dots) and 85% prestrain (round dots). The interconnect consists of $0.3~\mu m$ thick copper sandwiched by two $1.2~\mu m$ thick PI layers. The large variations in resistance are due to contact resistance in 2-point measurements.

Figure S4. Microscopic images showing cyclic testing results (after 25,000 cycles) for (a) 0.3 μm interconnect without prestrain; (b) 0.3 μm interconnect with 85% prestrain; (c) 4 μm interconnect without prestrain and (d) 4 μm interconnect with 18% prestrain. The uneven surfaces seen on the left and middle frames for the 4 μm interconnect are not cracks but rather due to much rougher morphology of the copper foils used in this case.

Figure S5. (a) Experiment and numerical analyses of the configurations of serpentine interconnects due to the application of different levels of prestrain; (b) experimental image of the serpentine interconnect and the fracture sites due to one-time stretching (286%), and FEA results for the strain distribution when stretched to the predicted total stretchability (304%),

for the case of 85% prestrain; (c) experimental image of the serpentine interconnect and the fracture sites due to cyclic stretching (with an amplitude of 39%), and FEA results on the strain distribution when stretched to the predicted elastic stretchability (31%), for the case of 18% prestrain. The interconnect consists of 4.0 μ m thick copper on 4.0 μ m thick PI layer. The color in the FEA results (**Figure S5a**) represents the distribution of out-of-plane displacement, with the minimum and maximum values (u_{min} , u_{max}) given by (0, 0), (54.5, 128.4), (112.0, 213.8), (194.8, 330.1) for ε_{pre} =0%, 40%, 80%, 160%, respectively.

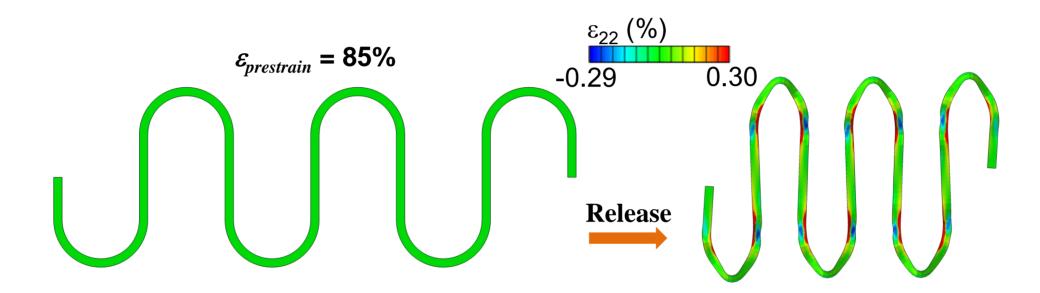
Figure S6. Influence of material parameters (**a** for metal modulus, and **b** for substrate modulus) on the maximum allowable prestrain for avoiding plastic deformation in the serpentine interconnects. The parameters adopted in the simulations are ($l_1=l_2=500 \, \mu m$, $w=50 \, \mu m$, m=3, $t_{metal}=1.0 \, \mu m$, $t_{PI1}=t_{PI2}=1.2 \, \mu m$, $t_{substrate}=1.0 \, m m$, $t_{substrate}=60 \, kPa$) in **Figure S6a**, and ($l_1=l_2=500 \, \mu m$, $w=50 \, \mu m$, m=3, $t_{metal}=1.0 \, \mu m$, $t_{PI1}=t_{PI2}=1.2 \, \mu m$, $t_{substrate}=1.0 \, m m$, $t_{metal}=1.0 \, m m$, t_{metal}

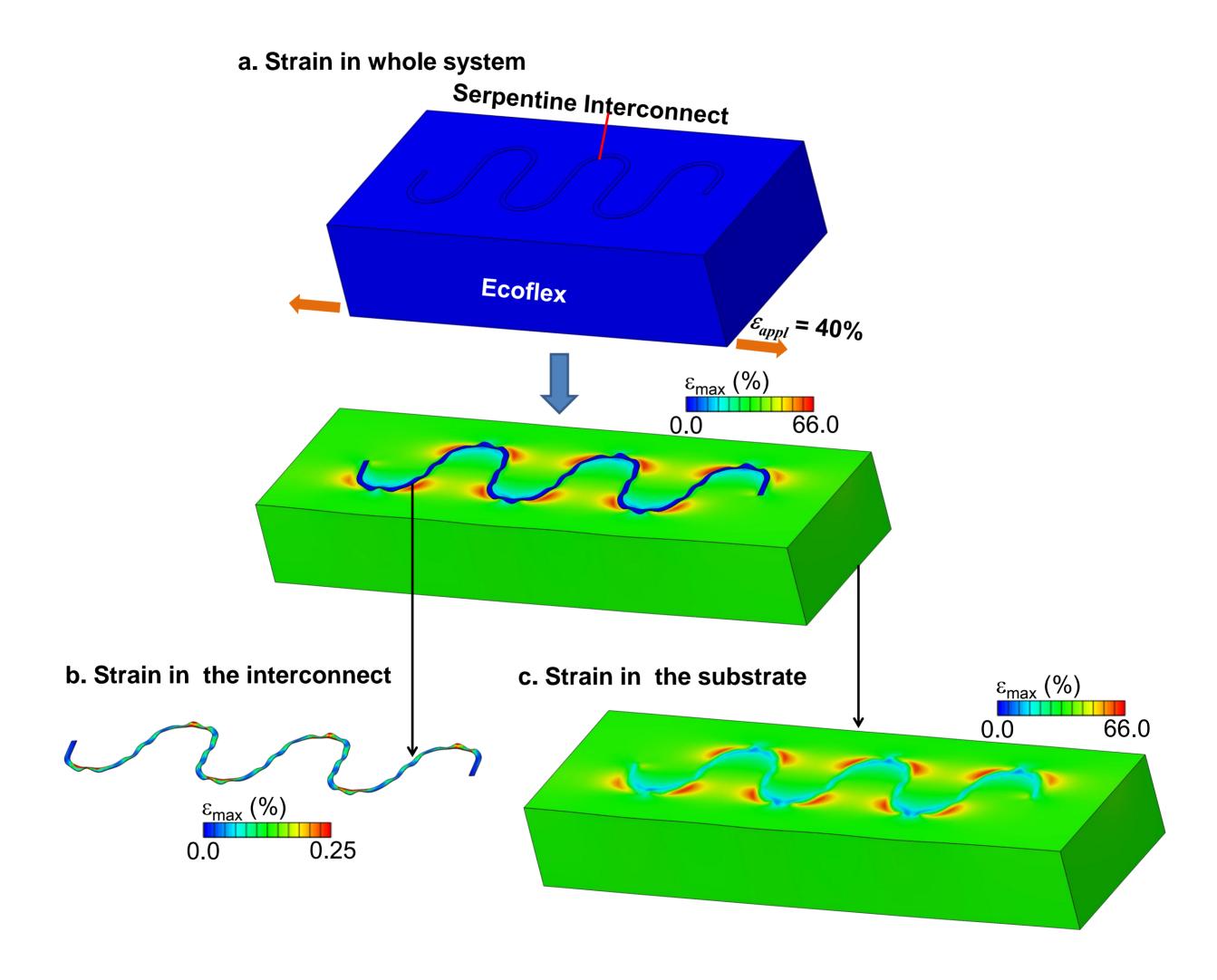
Figure S7. Influence of geometric parameters (**a** for the length/spacing ratio, **b** for substrate thickness, and **c** for metal thickness) on the maximum allowable prestrain for avoiding plastic deformation in the serpentine interconnects. The parameters adopted in the simulations are $(l_1=500 \text{ μm}, w=50 \text{ μm}, m=3, t_{metal}=1.0 \text{ μm}, t_{PI1}=t_{PI2}=1.2 \text{ μm}, t_{substrate}=1.0 \text{ mm}, E_{substrate}=60 \text{ kPa},$ $E_{metal}=119 \text{ GPa}$) in **Figure S7a**, $(l_1=l_2=500 \text{ μm}, w=50 \text{ μm}, m=3, t_{metal}=1.0 \text{ μm}, t_{PI1}=t_{PI2}=1.2 \text{ μm}, E_{substrate}=60 \text{ kPa}, E_{metal}=119 \text{ GPa})$ in **Figure S7b**, and $(l_1=l_2=500 \text{ μm}, w=50 \text{ μm}, m=3, t_{PI1}=t_{PI2}=1.2 \text{ μm}, t_{substrate}=1.0 \text{ mm}, E_{substrate}=60 \text{ kPa}, E_{metal}=119 \text{ GPa})$ in **Figure S7c**.

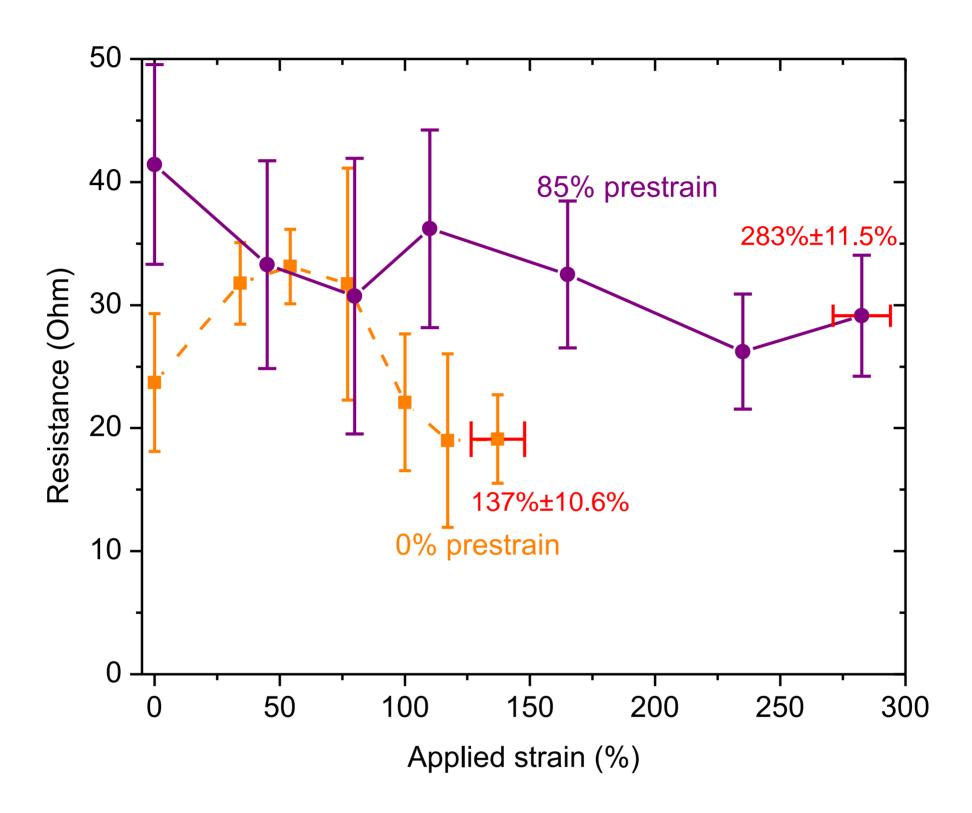
Figure S8. FEA results on deformations of serpentine interconnects under ε_{appl} =20%, for four different aspect ratios. The color represents the distribution of the maximum principal strain.

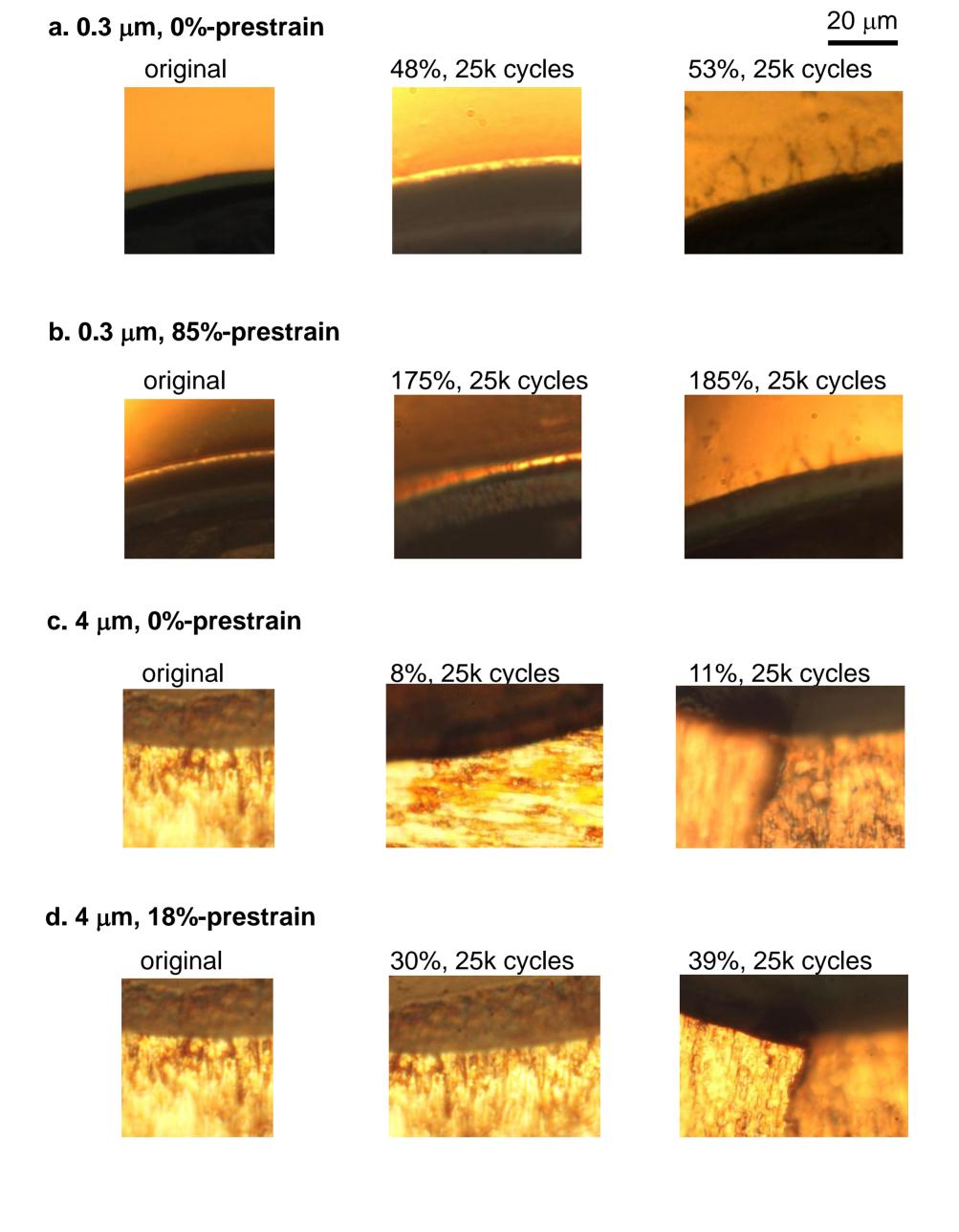
Figure S9. Influence of the length/spacing ratio on the elastic stretchability of serpentine interconnects for metal thicknesses of t_{metal} =0.3 and 3.0 um. The other parameters adopted in the simulations are l_1 =500 um, w=50 um, m=3, t_{PI1} = t_{PI2} =1.2 um, $t_{substrate}$ =1.0 mm, $E_{substrate}$ =60 kPa, E_{metal} =119 GPa.

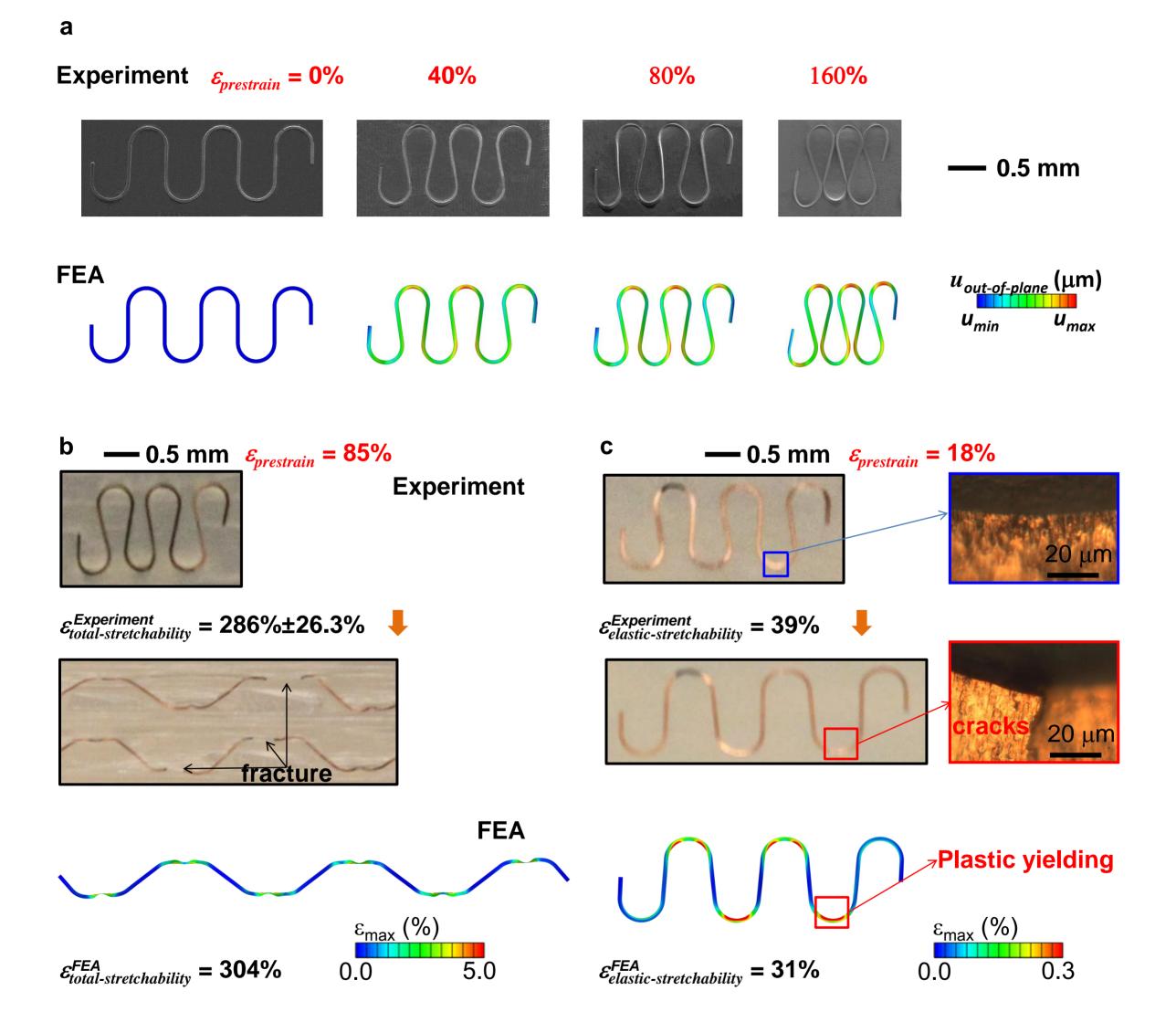
Figure S10. SEM images of the three-dimensional deformed configurations of the serpentine interconnects under 60% stretching. (a) sample consisting of 0.3 μ m thick copper sandwiched by two 0.3 μ m thick PI layers, and (b) sample consisting a 4.0 μ m thick copper on a 4.0 μ m thick PI layer.

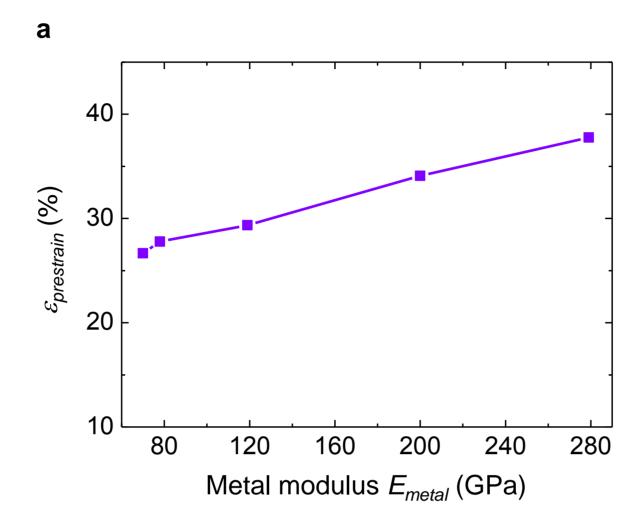


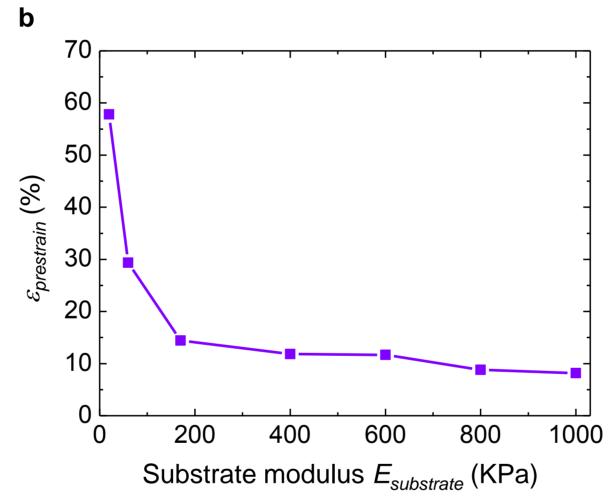


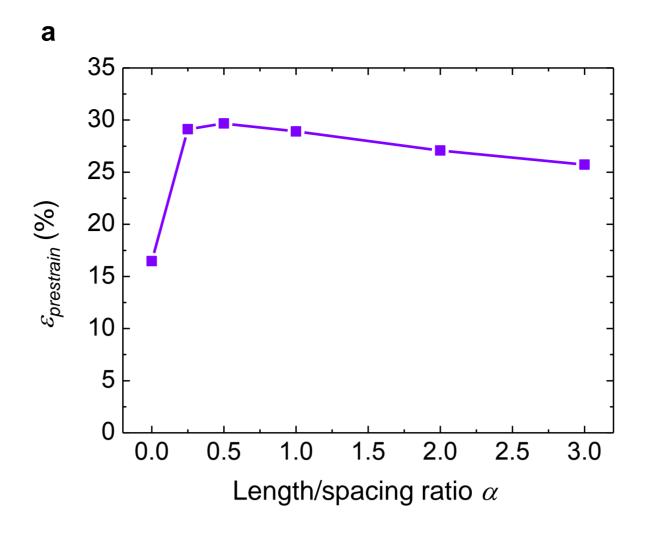


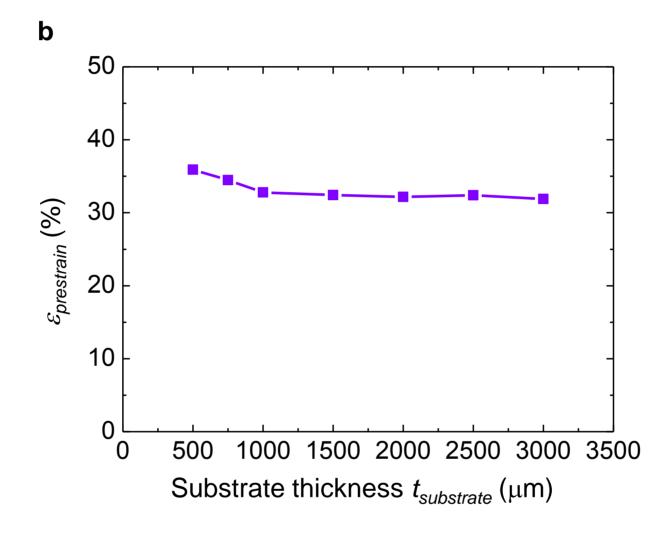


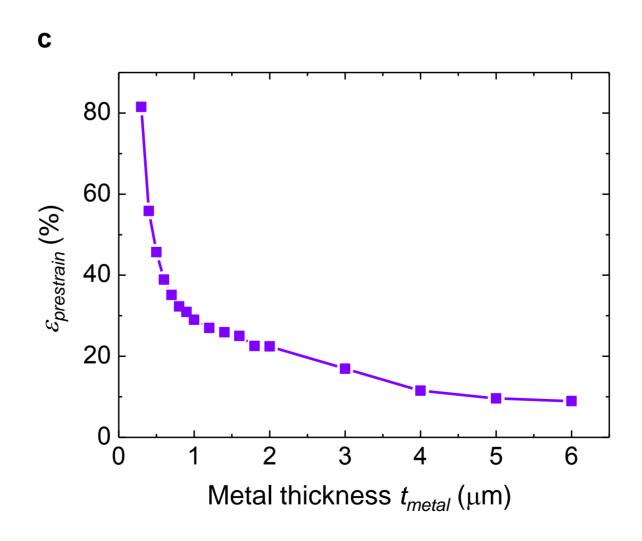


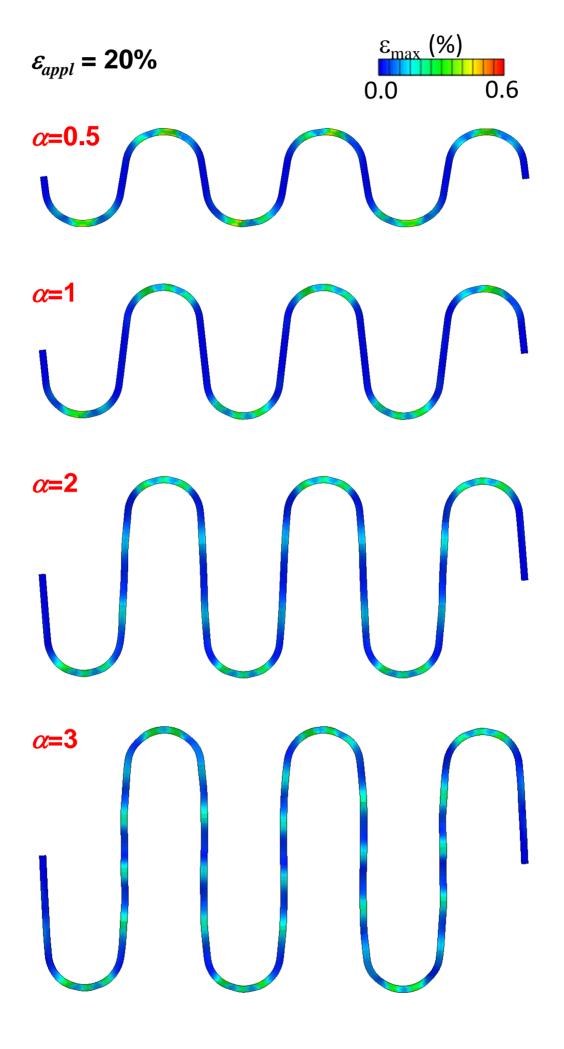


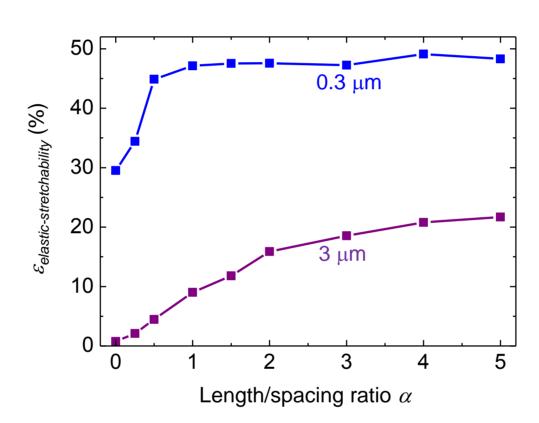




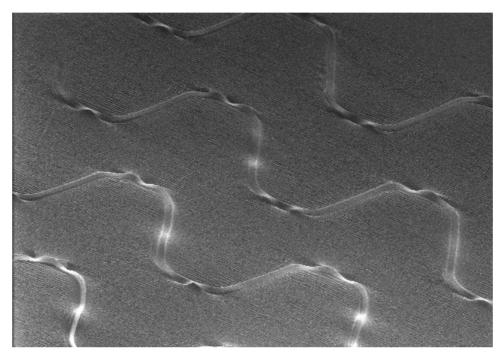






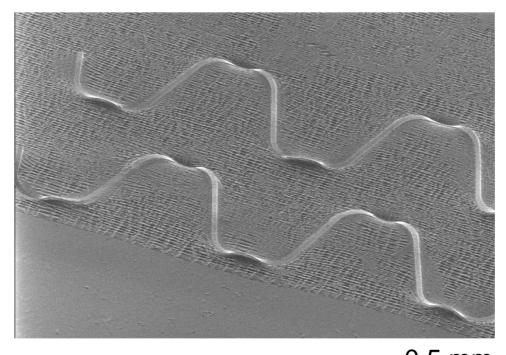


a. Thin (0.3 $\mu\text{m})$ interconnect – local wrinkling



____0.5 mm

b. Thick (4 μ m) interconnect – no wrinkling



-0.5 mm